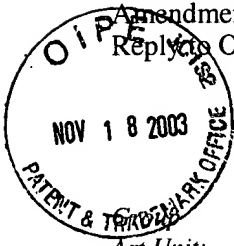


Application No. 09/633,002
Amendment dated November 13, 2003
Reply to Office Action dated June 17, 2003



RECEIVED
NOV 20 2003
TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CERTIFICATE OF MAILING

Art Unit: 1762
Attorney
Docket No.: NPO0005-01
Applicant: Keiji Ishibashi
Invention: A HOT ELEMENT CVD
APPARATUS AND A
METHOD FOR REMOVING
A DEPOSITED FILM
Serial No.: 09/633,002
Filed: August 4, 2000
Examiner: Wesley D. Markham

I HEREBY CERTIFY THAT THIS correspondence
is being deposited with the United States Postal
Service as First Class Mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450 on: November 13,
2003.

ANTHONY NIEWYK, REG. NO. 24, 871

Name of Registered Representative

Signature

November 13, 2003

Date

AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Final Office Action dated June 17, 2003, which had a period for
response which expired on September 17, 2003, which period has been extended by the enclosed
two-month Petition For Extension Of Time to expire on November 17, 2003, Applicant hereby
submits the following amendment:

Amendments to the Claims are reflected in the listing of claims which begins on page 2
of this paper.

Remarks begin on page 6 of this paper.